

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 1775

Application No.: 10/690,021

Examiner: L. XU

Filed: October 22, 2003

Docket No.: 117581

For: FERROELECTRIC FILM, FERROELECTRIC  
CAPACITOR AND METHOD OF  
FABRICATING THE SAME,  
FERROELECTRIC MEMORY,  
PIEZOELECTRIC ELEMENT AND  
SEMICONDUCTOR

**MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

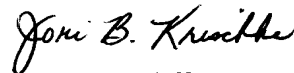
In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

☒ Applicants further request entry and consideration of the attached Information Disclosure Statement.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

The fees associated with this filing under are being paid electronically with this filing. The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,



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JAO:JBK/rav  
Date: October 3, 2006

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<p style="text-align: center;"><b>DEPOSIT ACCOUNT USE AUTHORIZATION</b> Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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